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July 19, 2001

Ms. Susan Jerome
Micron Technology, Inc.
P.O. Box 6
Boise, Idaho 83707

RE: U.S. Patent Application No. 09/590,795
For: METHODS FOR FORMING AND INTEGRATED CIRCUIT
STRUCTURES CONTAINING RUTHENIUM AND TUNGSTEN
CONTAINING LAYERS
Filed: June 8, 2000
Our Ref. No. 6047-53173

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Dear Susan:

Enclosed in connection with the above-referenced patent application are copies of an Office Action dated June 20, 2001 that we received from the U.S. Patent and Trademark Office on June 25, 2001, and the reply we filed today.

We will continue to keep you advised as further communications are received. In the meantime, if you have any questions, please do not hesitate to call.

Sincerely yours,

KLARQUIST SPARKMAN CAMPBELL
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Michael D. Jones

MJ:mgs
Enclosure
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